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SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/593,282	04/22/2008	118	1716	060711	
APPLICANTS Mitsunori Takeshita, Toyama, JAPAN; Tomoyuki Matsuda, Toyama, JAPAN; Mitsuhiro Hirano, Toyama, JAPAN; Akihiro Sato, Toyama, JAPAN; Shinya Morita, Toyama, JAPAN; Toshimitsu Miyata, Toyama, JAPAN; Koji Shibata, Toyama, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP2005/011714 06/27/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-205577 07/13/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/20/2008					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /NATHAN K FORD/ Acknowledged Examiner's Signature <input type="checkbox"/> Met after Allowance Initials					
		STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
		JAPAN	4	20	3
ADDRESS KRATZ, QUINTOS & HANSON, LLP 1420 K Street, N.W. 4th Floor WASHINGTON, DC 20005 UNITED STATES					
TITLE Substrate Processing Apparatus and Manufacturing Method for a Semiconductor Device					
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees		
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